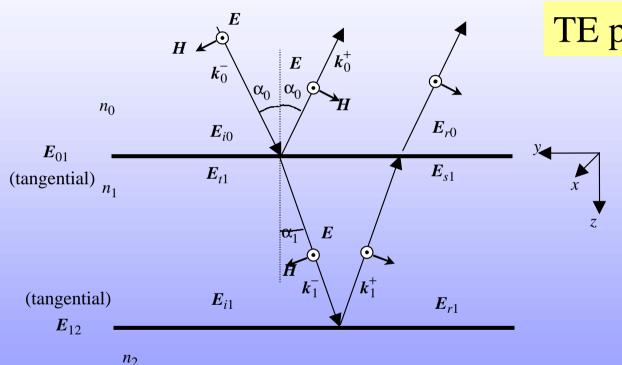
# Layered structures: transfer matrix formalism

#### Petr Kužel

- Interfaces between LHI media
- Transfer matrix formalism
  - Practically only one formula is to be known in order to calculate any structure
- Applications:
  - Antireflective coatings
  - Dielectric mirrors, Chirped mirrors
  - Laser output couplers
  - Beam-splitters
  - Beam-splitting mirrors
  - Interference filters

#### Transfer matrix formalism



#### TE polarization

$$E_{01} = E_{t1} + E_{s1}$$
$$\eta_0 H_{01} = (E_{t1} - E_{s1}) \gamma$$

$$E_{12} = E_{i1} + E_{r1}$$
$$\eta_0 H_{12} = (E_{i1} - E_{r1})\gamma$$

$$\left( \delta = n_1 \cos \alpha_1 \\
\delta = d_1 k_{z1} = \frac{2\pi}{\lambda} n_1 d_1 \cos \alpha_1 \right)$$

$$E_{i1} = E_{t1}e^{-i\delta}$$
$$E_{s1} = E_{r1}e^{-i\delta}$$

#### Introduction of transfer matrix

$$\begin{pmatrix} E_{01} \\ \eta_0 H_{01} \end{pmatrix} = \begin{pmatrix} \cos \delta & \frac{i \sin \delta}{\gamma} \\ i \gamma \sin \delta & \cos \delta \end{pmatrix} \begin{pmatrix} E_{12} \\ \eta_0 H_{12} \end{pmatrix}$$

Transfer matrix connects tangential fields on both ends of a layer For *j*-th layer:

$$M = \begin{pmatrix} m_{11} & m_{12} \\ m_{21} & m_{22} \end{pmatrix} = \begin{pmatrix} \cos \delta_j & \frac{i \sin \delta_j}{\gamma_j} \\ i \gamma_j \sin \delta_j & \cos \delta_j \end{pmatrix}$$

For the whole structure:

$$\begin{pmatrix} E_{01} \\ \eta_0 H_{01} \end{pmatrix} = M_1 M_2 \dots M_N \begin{pmatrix} E_{N,N+1} \\ \eta_0 H_{N,N+1} \end{pmatrix} = M_{tot} \begin{pmatrix} E_{N,N+1} \\ \eta_0 H_{N,N+1} \end{pmatrix}$$

# Reflection and transmission coefficients

$$\begin{pmatrix} E_{01} \\ \eta_0 H_{01} \end{pmatrix} = \begin{pmatrix} E_{i0} + E_{r0} \\ (E_{i0} - E_{r0}) \gamma_0 \end{pmatrix} = M_{tot} \begin{pmatrix} E_t \\ \gamma_t E_t \end{pmatrix} = M_{tot} \begin{pmatrix} E_{N,N+1} \\ \eta_0 H_{N,N+1} \end{pmatrix}$$

$$r = \frac{\gamma_0 m_{11} + \gamma_0 \gamma_t m_{12} - m_{21} - \gamma_t m_{22}}{\gamma_0 m_{11} + \gamma_0 \gamma_t m_{12} + m_{21} + \gamma_t m_{22}}$$
$$t = \frac{2\gamma_0}{\gamma_0 m_{11} + \gamma_0 \gamma_t m_{12} + m_{21} + \gamma_t m_{22}}$$

polarisation TE:  $\gamma_j = n_j \cos \alpha_j$   $\delta_j = \omega n_j d_j \cos \alpha_j / c$  polarisation TM:  $\gamma_j = n_j / \cos \alpha_j$   $\delta_j = \omega n_j d_j \cos \alpha_j / c$  normal incidence:  $\gamma_j = n_j$   $\delta_j = \omega n_j d_j / c$ 

#### Generalization

The formalism is also valid for

• absorbing layers; j-th layer absorbs:  $N_j = n_j - i\kappa_j$ 

$$\cos \alpha_j = \frac{\sqrt{N_j^2 - n_0^2 \sin^2 \alpha_0}}{N_j}$$

• layers where total reflection occurs; total reflection on *j*-th layer:

$$\cos \alpha_j = -i \frac{\sqrt{n_0 \sin^2 \alpha_0 - n_j^2}}{n_j}$$

 $\delta_j$  and  $\gamma_j$  become imaginary; one introduces:  $\Delta_j = i\delta_j$  and  $\Gamma_j = i\gamma_j$ , where  $\Delta_j$  and  $\Gamma_j$  are real. The transfer matrix becomes:

$$M_{j} = \begin{pmatrix} \cosh \Delta_{j} & i \frac{\sinh \Delta_{j}}{\Gamma_{j}} \\ -i\Gamma_{j} \sinh \Delta_{j} & \cosh \Delta_{j} \end{pmatrix}$$

#### **Applications**

Optical elements and coatings are designed for given incidence angle Specific layer thicknesses are frequently used in stacks:

• quarter-wave  $(\lambda/4)$  layer

$$\delta = \frac{2\pi}{\lambda} \underbrace{n_1 d_1 \cos \alpha_1}_{\lambda/4} = \frac{\pi}{2}$$

$$M = \begin{pmatrix} 0 & i/\gamma \\ i\gamma & 0 \end{pmatrix}$$

• half-wave  $(\lambda/2)$  layer

$$\delta = \frac{2\pi}{\lambda} \underbrace{n_1 d_1 \cos \alpha_1}_{\lambda/2} = \pi$$

$$M = \begin{pmatrix} -1 & 0 \\ 0 & -1 \end{pmatrix}$$

• quarter-wave  $(\lambda/4-\lambda/4)$  bilayer

$$M = \begin{pmatrix} 0 & i/\gamma_1 \\ i\gamma_1 & 0 \end{pmatrix} \begin{pmatrix} 0 & i/\gamma_2 \\ i\gamma_2 & 0 \end{pmatrix} = \begin{pmatrix} -\gamma_2/\gamma_1 & 0 \\ 0 & -\gamma_1/\gamma_2 \end{pmatrix}$$

### Antireflective single layer

Let's try  $\lambda/4$ -layer (then waves with  $\lambda/2$  phase delay will interfere)

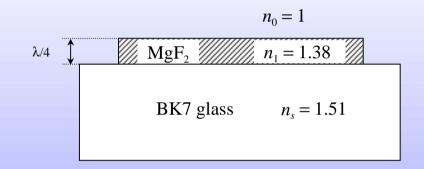
$$M = \begin{pmatrix} 0 & i/\gamma_1 \\ i\gamma_1 & 0 \end{pmatrix}$$

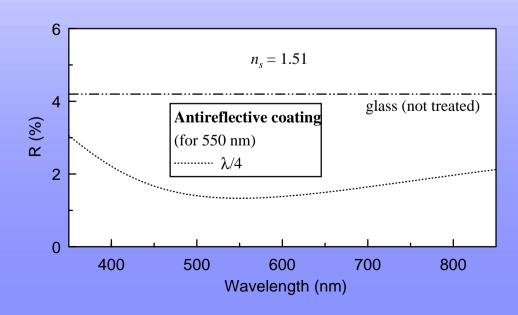
$$r = \frac{\gamma_0 \gamma_s - \gamma_1^2}{\gamma_0 \gamma_s + \gamma_1^2} = \frac{n_s - n_1^2}{n_s + n_1^2}$$

$$n_1 = \sqrt{n_s}$$

Broadband

Less efficient (no degree of freedom for  $n_1$ )





#### Antireflective bilayer

• quarter-wave  $(\lambda/4-\lambda/4)$  bilayer

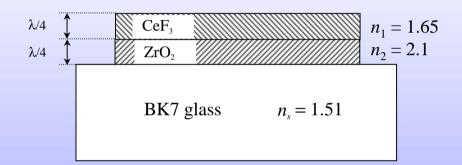
$$M = \begin{pmatrix} -\gamma_2/\gamma_1 & 0 \\ 0 & -\gamma_1/\gamma_2 \end{pmatrix}$$

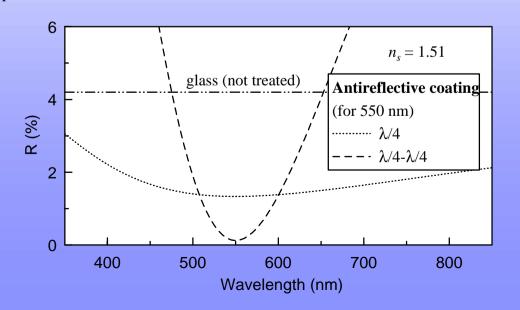
$$r = \frac{\gamma_2^2 \gamma_0 - \gamma_s \gamma_1^2}{\gamma_2^2 \gamma_0 + \gamma_s \gamma_1^2} = \frac{n_2^2 - n_s n_1^2}{n_2^2 + n_s n_1^2}$$

$$\frac{n_2}{n_1} = \sqrt{n_s}$$

V-like shape (narrow frequency range)

More efficient (one degree of freedom for  $n_1$ ,  $n_2$ )





### Broadband AR coating

trilayer structure  $(\lambda/4-\lambda/4-\lambda/4)$ 

yer structure 
$$(\lambda/4 - \lambda/4 - \lambda/4)$$

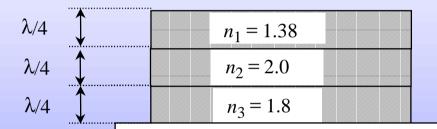
$$M = \begin{pmatrix} 0 & -i\frac{\gamma_2}{\gamma_1\gamma_3} \\ -i\frac{\gamma_1\gamma_3}{\gamma_2} & 0 \end{pmatrix}$$

$$\lambda/4$$

$$\lambda/4$$

$$r = \frac{\gamma_2^2 \gamma_0 \gamma_s - \gamma_1^2 \gamma_3^2}{\gamma_2^2 \gamma_0 \gamma_s + \gamma_1^2 \gamma_3^2} = \frac{n_2^2 n_s - n_1^2 n_3^2}{n_2^2 n_s + n_1^2 n_3^2}$$

$$\frac{n_1 n_3}{n_2} = \sqrt{n_s}$$



BK7 glass  $n_s = 1.51$ 

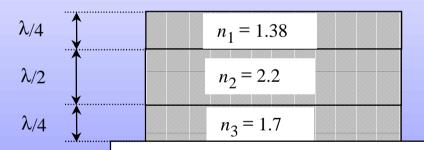
# Broadband AR coating

- trilayer structure  $(\lambda/4-\lambda/2-\lambda/4)$ : similar to a quarter-wave bilayer at the resonant wavelength
- half-wave layer helps to extend the antireflective range

$$M = \begin{pmatrix} \gamma_3/\gamma_1 & 0 \\ 0 & \gamma_1/\gamma_3 \end{pmatrix} \qquad \lambda/4$$

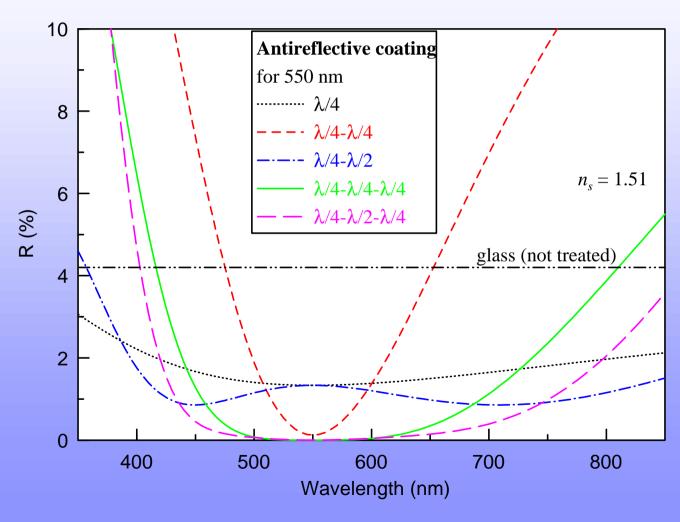
$$r = \frac{-\gamma_3^2 \gamma_0 + \gamma_s \gamma_1^2}{\gamma_3^2 \gamma_0 + \gamma_s \gamma_1^2} = \frac{n_s n_1^2 - n_3^2}{n_3^2 + n_s n_1^2} \qquad \lambda/4$$

$$\frac{n_3}{n_1} = \sqrt{n_s}$$



BK7 glass  $n_s = 1.51$ 

# Antireflective coating: summary



#### Dielectric mirrors

1 bilayer  $(n_L \ll n_H)$ :

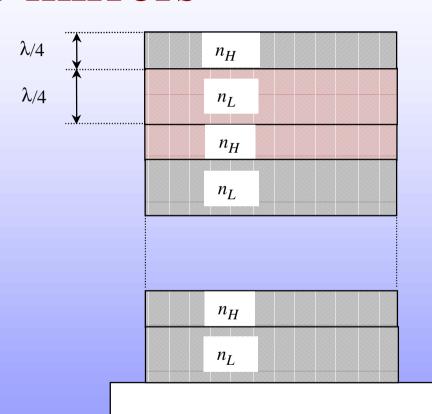
$$M = \begin{pmatrix} -n_L/n_H & 0 \\ 0 & -n_H/n_L \end{pmatrix}$$

*N* bilayers:

$$M = \begin{pmatrix} \left(-n_L/n_H\right)^N & 0\\ 0 & \left(-n_H/n_L\right)^N \end{pmatrix}$$

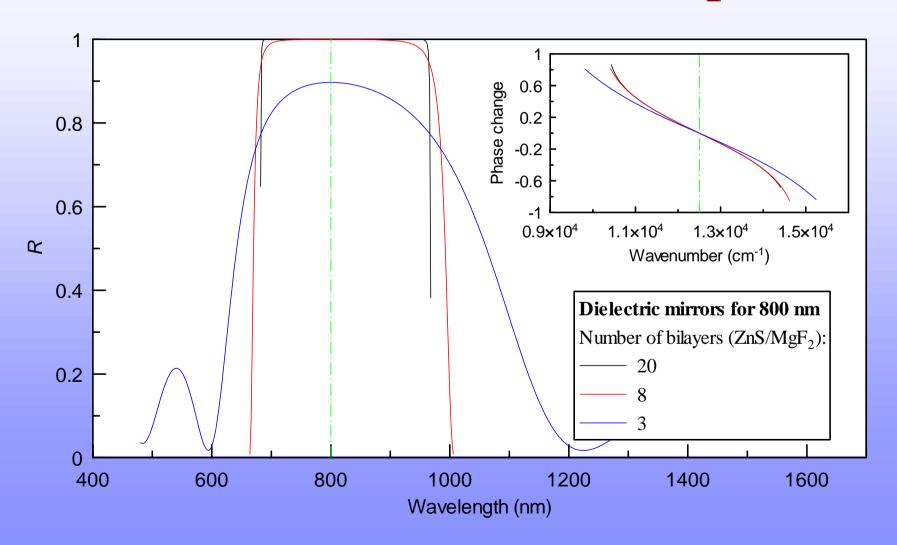
Reflectivity:

$$R = \left(\frac{(1/n_s)(n_L/n_H)^{2N} - 1}{(1/n_s)(n_L/n_H)^{2N} + 1}\right)^2$$



 $n_s$ 

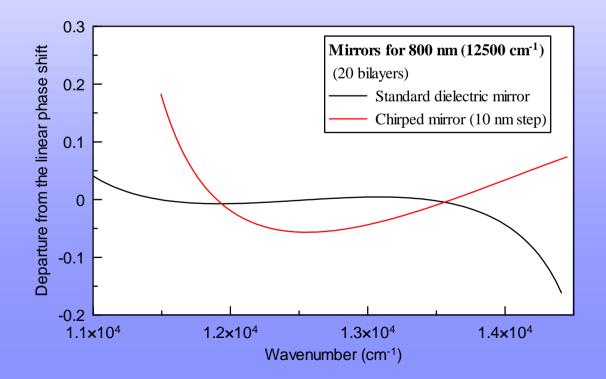
# Dielectric mirrors: example



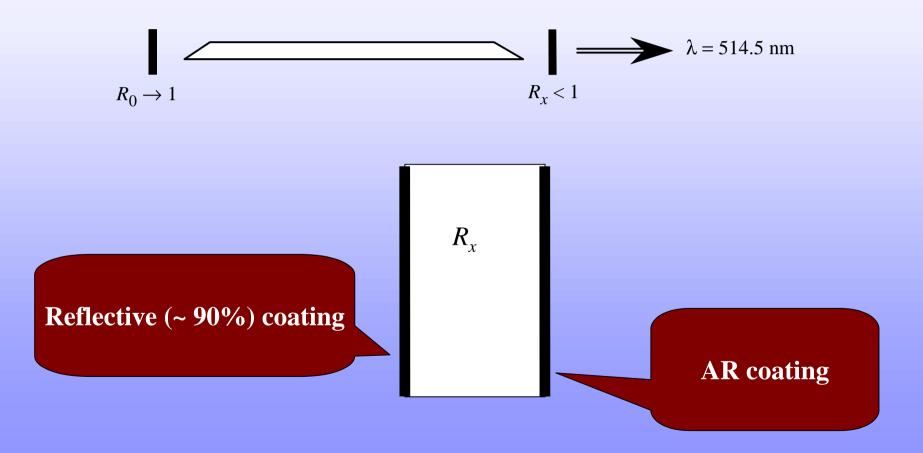
# Chirped dielectric mirrors

The resonant wavelength is linearly tuned along the stack of bilayers

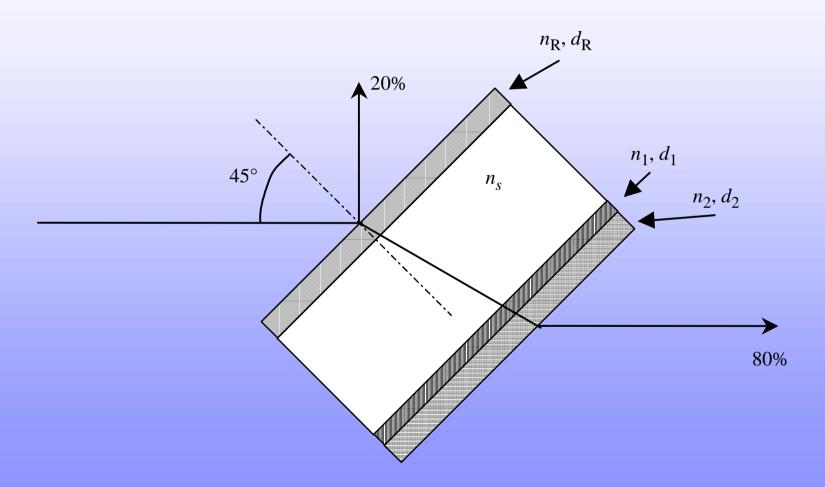
- Different wavelengths are reflected at different depths → different optical paths
- Adding or compensating of a chirp of the pulses



# Laser output coupler



# Beamsplitter



### Beamsplitting mirror

- Separation of harmonic frequencies (e.g. Nd:YAG fundamental beam at 1064 nm and its second harmonic at 532 nm)
- Long-pass or cut-off filters

#### Example of solution:

- 1) Stack of  $\lambda/4$  bilayers forming a dielectric mirror for 1064 nm These layers are  $\lambda/2$  for the second harmonics so it passes through unchanged
- 2) We add below an AR coating for 532 nm 1064 nm component does not penetrate down to these layers

Result: 1064 nm is reflected, 532 nm is transmitted

• Sometimes a detuning of a resonant wavelength is used in several layers of the HR coating: it can smooth the unwanted interference maxima and minima.

### Interference band-pass filters

#### Contain:

- Stacks of high-reflecting bilayers
- Antireflective coatings
- Fabry-Pérot cavities
- Detuning of the resonant wavelength is also often used for smoothing of the interferences